

PATENT ASSIGNMENT

Electronic Version v1.1  
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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	Release of Second Lien Security Interest in Patents

CONVEYING PARTY DATA

Name	Execution Date
CIT Lending Services Corporation	06/01/2012

RECEIVING PARTY DATA

Name:	Deposition Sciences, Inc.
Street Address:	3300 Coffey Lane
City:	Santa Rosa
State/Country:	CALIFORNIA
Postal Code:	95403

PROPERTY NUMBERS Total: 21

Property Type	Number
Patent Number:	7008518
Patent Number:	6331914
Patent Number:	6402902
Patent Number:	6197428
Patent Number:	5714009
Patent Number:	5616224
Patent Number:	5072109
Patent Number:	6107564
Patent Number:	5923471
Patent Number:	6485616
Patent Number:	5849162
Patent Number:	7176606
Patent Number:	4879140
Application Number:	10840274
Application Number:	10959504

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Application Number:	10981682
Application Number:	10960621
Application Number:	60796522
Application Number:	60819403
Application Number:	60836698
Application Number:	09537095

**CORRESPONDENCE DATA**

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ATTORNEY DOCKET NUMBER:	ADLT(RELEASE OF CIT LIEN)
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NAME OF SUBMITTER:	Minette M. Tayco
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Total Attachments: 5  
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**RELEASE OF SECOND LIEN SECURITY INTEREST IN PATENTS**

June 1, 2012

The undersigned hereby acknowledges that the security interest in the patents set forth on Schedule 1 attached hereto from Deposition Sciences, Inc., an Ohio corporation, to CIT Lending Services Corporation, in its capacity as administrative and collateral agent for certain secured parties pursuant to the Second Lien Security Agreement, dated as of June 1, 2007, has been fully and completely released.

Such security interest was recorded in the United States Patent and Trademark Office at Reel/Frame 019390/0176 on June 6, 2007, and this Release shall include any reissue, continuation, continuation-in-part or extension thereof, and all proceeds thereof, including, without limitation, any and all causes of action which may exist by reason of infringement thereof as of the date of execution of this Release.

[Signature Page Follows]

**CIT LENDING SERVICES CORPORATION,**  
as Agent

By: Michael J LaManes  
Name: Michael L. LaManes  
Title: Vice President

**SCHEDULE 1  
TO  
RELEASE OF SECURITY INTEREST IN PATENTS**

Schedule I to First Lien Security Agreement (Patents)  
Deposition Sciences, Inc.

**PLEDGOR: DEPOSITION SCIENCES, INC.**

**U.S. Patents**

Short Title	App. No.	Pat. No.	Eff. Filing Date	Issue Date
Method and Apparatus for Monitoring Optical Characteristics of Thin Films in a Deposition Process	11/036,326	7,008,518	1/18/2005	3/7/2006
An Optical Interference Coating Capable Of Withstanding Severe Temperature Environments	09/332,092	6,331,914	6/14/1999	12/18/2001
Apparatus And Method For Reliable Return Current Path For Sputtering Process	08/388,191	6,402,902	2/13/1995	6/11/2002
Novel Gemstones And Decorative Objects Comprising A Substrate And An Optical Interference Film	08/296,779	6,197,428	8/26/1994	3/6/2001
Apparatus For Generating Large Distributed Plasmas By Means Of Plasma-Guided Microwave Power	08/371,195	5,714,009	1/11/1995	2/3/1998
Apparatus For Reducing The Intensity And Frequency Of The Arcs Which Occur During A Sputtering Process	08/437,816	5,616,224	5/9/1995	4/1/1997
Photocell Array With Multi-Spectral Filter	07/490,043	5,072,109	3/7/1990	12/10/1991
Solar Cell Cover And Coating	08/972,372	6,107,564	11/18/1997	8/22/2000
An Optical Interference Coating Capable Of Withstanding Severe Temperature Environments	08/753,574	5,923,471	11/26/1996	7/13/1999
System And Method Of Coating Substrates With Improved Capacity And Uniformity	09/473,980	6,485,616	12/29/1999	11/26/2002
Sputtering Device and Method for Reactive Sputtering	08/428,612	5,849,162	4/25/1995	12/15/1998
Red, Orange, and Yellow Emitting Lamp Burners with Improved Color Purity and Lumen Output	10/839,259	7,176,606	5/6/2004	2/13/2007
Method for Making Pigment Flakes	07/274,380	4,879,140	11/21/1988	11/7/1989

**PLEDGOR: DEPOSITION SCIENCES, INC.**

**U.S. Patent Applications**

Short Title	App. No.	Eff. Filing Date
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Masks for Improved Deposition Uniformity on Non-Substrates Planar	10/840,274	5/7/2004
Apparatus And Process For High Rate Deposition Of Rutile Titanium Dioxide	10/959,504	10/7/2004
Optical Coatings and Methods	10/981,682	11/5/2004
System and Method for Feedforward Control in Thin Film Coating Processes	10/960,621	10/8/2004
Spatially Pulsed Reactive Sputtering	60/796,522	5/2/2006
Sol Dip Coating Method for a Highly Complex Shape	60/819,403	7/10/2006
Temporally Pulsed Reactive Sputtering	60/836,698	8/10/2006
System And Method Of Coating Substrates And Assembling Devices Having Coated Elements	09/537,095	3/29/2000

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